

Docket No. 236518US26YA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Andrej S. MITROVIC

SERIAL NO: 10/673,138

GAU: 2128

FILED: September 30, 2003

EXAMINER: Akash, Saxena

FOR: SYSTEM AND METHOD FOR USING FIRST-PRINCIPLES SIMULATION TO FACILITATE A SEMICONDUCTOR MANUFACTURING PROCESS

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Applicant(s) wish to disclose the following information.

REFERENCES

- ☒ Submitted herewith is a Chinese Office Action (with English translation) dated June 19, 2009 for the Examiner's consideration. US reference no. 5,719,796A was filed in an Information Disclosure Statement dated May 26, 2006 and the Naomi Yonemurea, "Heat Analysis on Insulated Metal Substrates" reference was cited by the Examiner in related Application No. 10/673,507 in an Office Action dated September 22, 2005.
- ☒ Credit card payment is being made online (if electronically filed), or is attached hereto (if paper filed), in the amount required under 37 CFR §1.17(p).

RELATED CASES

- ☐ Attached is a list of applicant's pending application(s), published application(s) or issued patent(s) which may be related to the present application. In accordance with the waiver of 37 CFR 1.98 dated September 21, 2004, copies of the cited pending applications are not provided. Cited published and/or issued patents, if any, are listed on the attached PTO form 1449.
- ☐ Credit card payment is being made online (if electronically filed), or is attached hereto (if paper filed), in the amount required under 37 CFR §1.17(p).

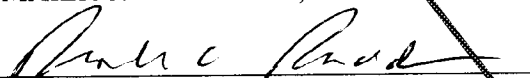
CERTIFICATION

- ☒ Each item of information not previously filed or cited by the Examiner in this or a related application was first cited in the communication from the foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- ☐ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application and, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

- ☐ Please charge any additional fees for the papers being filed herewith and for which no payment is enclosed herewith, or credit any overpayment to deposit account number 15-0030

Respectfully submitted,

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